



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1763

PATENT APPLICATION
Docket No. 5484-087
Client No. PX1293-US/SSM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yong-Kil Kim Conf. No. 2611
Serial No. 10/072,443 Examiner: Zervigon, Rudy
Filed: February 5, 2002 Art Unit: 1763
For: GAS DISTRIBUTION APPARATUS OF SEMICONDUCTOR
EQUIPMENT

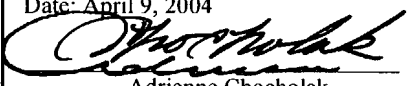
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RESPONSE AFTER FINAL REJECTION UNDER 37 CFR 1.116

This paper is responsive to the Final Office Action mailed 17 February 2004.
A **Listing of Claims** is presented for the Examiner's convenience and begins on page 2 of this paper.
Remarks/Arguments begin on page 4 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
Date: April 9, 2004

Adrienne Chocholak